

Electronic Patent Application Fee Transmittal

Application Number:	10552262			
Filing Date:	05-Oct-2005			
Title of Invention:	Method for removing silicon oxide film and processing apparatus			
First Named Inventor/Applicant Name:	Kazuhide Hasebe			
Filer:	Tayan Bipinchandra Patel/Lori Boyd			
Attorney Docket Number:	33082M275			
Filed as Large Entity				
U.S. National Stage under 35 USC 371 Filing Fees				
Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:				
Pages:				
Claims:				
Miscellaneous-Filing:				
Petition:				
Patent-Appeals-and-Interference:				
Post-Allowance-and-Post-Issuance:				
Extension-of-Time:				
Extension - 2 months with \$0 paid	1252	1	490	490

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Miscellaneous:				
Total in USD (\$)				490